



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 26, 2025

IGI Report Number **LG751514987**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **9.37 X 6.94 X 4.81 MM**

GRADING RESULTS

Carat Weight **3.04 CARATS**

Color Grade **E**

Clarity Grade **VS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

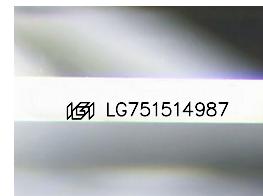
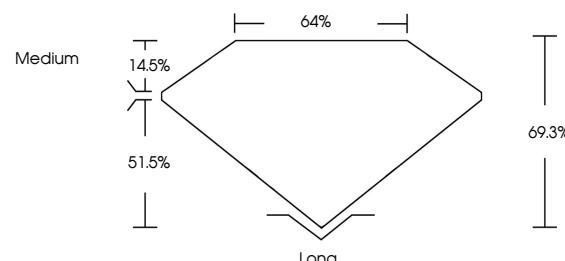
Fluorescence **NONE**

Inscription(s) **IGI LG751514987**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

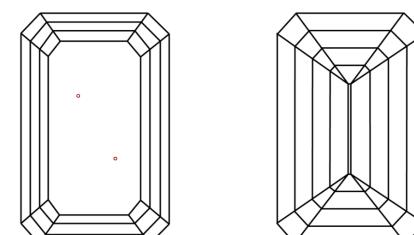
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG751514987
Report verification at igi.org

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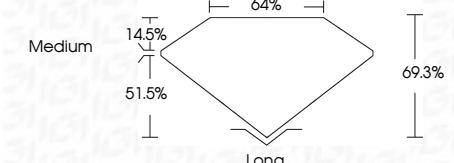
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November 26, 2025	IGI Report No LG751514987	EMERALD CUT	3.04 CARATS	E	VS 2	69.3%	64%	Medium	Long	EXCELLENT	EXCELLENT	NONE	IGI LG751514987
Carat Weight	9.37 X 6.94 X 4.81 MM	Color Grade	Clarity Grade	Depth	Table	Grade	Culet	Polish	Symmetry	Fluorescence	Inscription(s)	Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	
Clarity Grade		Very Light	Very Light										
Depth		Light	Light										
Table													
Grade													

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